

SUPPLEMENTAL APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Number:: 10/565,2006
 Application Date:: 01/24/06
 Application Type:: REGULAR
 Subject Matter:: UTILITY
 CD-ROM or CD-R?: NONE
 Title:: GAS REACTION SYSTEM AND SEMICONDUCTOR PROCESSING APPARATUS
 Attorney Docket Number:: 284901US26PCT
 Total Drawing Sheets:: 8

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
 Primary Citizenship Country:: Japan
 Status:: FULL CAPACITY
 Given Name:: Hachishiro
 Family Name:: IIZUKA
 City of Residence:: Nirasaki-shi
 State or Province of Residence:: Yamanashi
 Country of Residence:: Japan
 Street of Mailing Address:: c/o TOKYO ELECTRON AT LIMITED, 650, Mitsuzawa, Hosaka-cho
 City of Mailing Address:: Nirasaki-shi
 State or Province of Mailing Address:: Yamanashi
 Country of Mailing Address:: Japan
 Postal or Zip Code of Mailing Address:: 407-0192

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP04/10895	07/23/04

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2003-279970	Japan	07/25/03	YES

ASSIGNMENT INFORMATION

Assignee Name::	TOKYO ELECTON LIMITED
Street of Mailing Address::	3-6, Akasaka 5-chome, Minato-ku
City of Mailing Address::	Tokyo
Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	107-8481